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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/772,510	02/05/2004	Detlef Michelsson	21295.74 (H5742US)	5672
29127	7590	02/13/2008	EXAMINER	
HOUSTON ELISEEVA			FUJITA, KATRINA R	
4 MILITIA DRIVE, SUITE 4			ART UNIT	PAPER NUMBER
LEXINGTON, MA 02421			2624	
			MAIL DATE	DELIVERY MODE
			02/13/2008	PAPER

**Please find below and/or attached an Office communication concerning this application or proceeding.**

The time period for reply, if any, is set in the attached communication.

<b>Advisory Action Before the Filing of an Appeal Brief</b>	Application No.	Applicant(s)
	10/772,510 Examiner Katrina Fujita	MICHELSSON, DETLEF Art Unit 2624

--The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

THE REPLY FILED 30 January 2008 FAILS TO PLACE THIS APPLICATION IN CONDITION FOR ALLOWANCE.

1.  The reply was filed after a final rejection, but prior to or on the same day as filing a Notice of Appeal. To avoid abandonment of this application, applicant must timely file one of the following replies: (1) an amendment, affidavit, or other evidence, which places the application in condition for allowance; (2) a Notice of Appeal (with appeal fee) in compliance with 37 CFR 41.31; or (3) a Request for Continued Examination (RCE) in compliance with 37 CFR 1.114. The reply must be filed within one of the following time periods:

a)  The period for reply expires 3 months from the mailing date of the final rejection.

b)  The period for reply expires on: (1) the mailing date of this Advisory Action, or (2) the date set forth in the final rejection, whichever is later. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of the final rejection.

Examiner Note: If box 1 is checked, check either box (a) or (b). ONLY CHECK BOX (b) WHEN THE FIRST REPLY WAS FILED WITHIN TWO MONTHS OF THE FINAL REJECTION. See MPEP 706.07(f).

Extensions of time may be obtained under 37 CFR 1.136(a). The date on which the petition under 37 CFR 1.136(a) and the appropriate extension fee have been filed is the date for purposes of determining the period of extension and the corresponding amount of the fee. The appropriate extension fee under 37 CFR 1.17(a) is calculated from: (1) the expiration date of the shortened statutory period for reply originally set in the final Office action; or (2) as set forth in (b) above, if checked. Any reply received by the Office later than three months after the mailing date of the final rejection, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

NOTICE OF APPEAL

2.  The Notice of Appeal was filed on \_\_\_\_\_. A brief in compliance with 37 CFR 41.37 must be filed within two months of the date of filing the Notice of Appeal (37 CFR 41.37(a)), or any extension thereof (37 CFR 41.37(e)), to avoid dismissal of the appeal. Since a Notice of Appeal has been filed, any reply must be filed within the time period set forth in 37 CFR 41.37(a).

AMENDMENTS

3.  The proposed amendment(s) filed after a final rejection, but prior to the date of filing a brief, will not be entered because

(a)  They raise new issues that would require further consideration and/or search (see NOTE below);

(b)  They raise the issue of new matter (see NOTE below);

(c)  They are not deemed to place the application in better form for appeal by materially reducing or simplifying the issues for appeal; and/or

(d)  They present additional claims without canceling a corresponding number of finally rejected claims.

NOTE: \_\_\_\_\_. (See 37 CFR 1.116 and 41.33(a)).

4.  The amendments are not in compliance with 37 CFR 1.121. See attached Notice of Non-Compliant Amendment (PTOL-324).

5.  Applicant's reply has overcome the following rejection(s): \_\_\_\_\_.

6.  Newly proposed or amended claim(s) \_\_\_\_\_ would be allowable if submitted in a separate, timely filed amendment canceling the non-allowable claim(s).

7.  For purposes of appeal, the proposed amendment(s): a)  will not be entered, or b)  will be entered and an explanation of how the new or amended claims would be rejected is provided below or appended.

The status of the claim(s) is (or will be) as follows:

Claim(s) allowed: None.

Claim(s) objected to: None.

Claim(s) rejected: 3-16 and 27-34.

Claim(s) withdrawn from consideration: None.

AFFIDAVIT OR OTHER EVIDENCE

8.  The affidavit or other evidence filed after a final action, but before or on the date of filing a Notice of Appeal will not be entered because applicant failed to provide a showing of good and sufficient reasons why the affidavit or other evidence is necessary and was not earlier presented. See 37 CFR 1.116(e).

9.  The affidavit or other evidence filed after the date of filing a Notice of Appeal, but prior to the date of filing a brief, will not be entered because the affidavit or other evidence failed to overcome all rejections under appeal and/or appellant fails to provide a showing a good and sufficient reasons why it is necessary and was not earlier presented. See 37 CFR 41.33(d)(1).

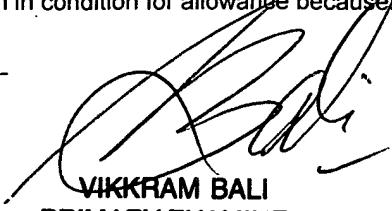
10.  The affidavit or other evidence is entered. An explanation of the status of the claims after entry is below or attached.

REQUEST FOR RECONSIDERATION/OTHER

11.  The request for reconsideration has been considered but does NOT place the application in condition for allowance because  
See attachment.

12.  Note the attached Information Disclosure Statement(s). (PTO/SB/08) Paper No(s). \_\_\_\_\_

13.  Other: \_\_\_\_\_

  
VIKKRAM BALI  
PRIMARY EXAMINER

Attachment for Advisory Action, Paper No. 20080211

***Response to Arguments***

Summary of Remarks (@ response page labeled 9): "The segmentation suggested by Shibata has nothing to do with the segmentation in order to achieve the same image content after a certain number of captured image fields."

Examiner's Response: Disagreed. As the Examiner pointed out in the Office Action, each die contains the same pattern and as such, as each die is separated into segments, the same image content would be attained at each die.

Summary of Remarks (@ response page labeled 9): "Shibata does not show the allocation of logical SAW-segments to the image field segments."

Examiner's Response: The die is broken into segments as addressed above and each conditioning image is broken into regions as cited in the Office Action ("detected image is divided into regions of predetermined size" at paragraph 0044, line 2). Therefore, the image field segments and logical SAW segments are allocated to each other for each die and are thus identical as subsequent dies are imaged since each die contains the same pattern.

Summary of Remarks (@ response page labeled 9): The Shibata reference discloses comparing adjacent chips with each other, which is not the case with Applicant's invention, which compares image field segments which have the same content.

Examiner's Response: As adjacent chips are compared with each other in the Shibata reference and each chip, or die, contains the same pattern and accordingly divided into segments the same as described above, comparison is done between image field segments that have the same content.

Summary of Remarks (@ response page labeled 9): The Shibata reference does not take "into account the fact that the size of the SAWs varies greatly depending on the stepper and die size (design)."

Examiner's Response: This particular aspect upon which applicant relies is not recited in the rejected claims. Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims. See *In re Van Geuns*, 988 F.2d 1181, 26 USPQ2d 1057 (Fed. Cir. 1993).

Summary of Remarks (@ response page labeled 9): The Park reference does not disclose "as the camera travels over the wafer an identical allocation of logical SAW segments to image field segments".

Examiner's Response: This argument was previously addressed in the Final Office Action and will not be repeated herein.

Summary of Remarks (@ response page labeled 9): A person skilled in the art would not consider the Park reference.

Examiner's Response: As stated in the Office Action, the Park reference is indeed analogous art as it describes "a system in the same field of endeavor of wafer defect inspection" at Office Action, page 6. The Examiner also provided motivation for combining the teachings of the Park reference with the Shibata reference at page 7 of the Office Action.